

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q97348

Norifumi FUJIMURA, et al.

Appln. No.: 10/594,252

Group Art Unit: 2812

Confirmation No.: 3373

Examiner: Alexander G GHYKA

Filed: September 26, 2006

For: METHOD AND APPARATUS FOR FORMING OXYNITRIDE FILM AND NITRIDE FILM, OXYNITRIDE FILM, NITRIDE FILM, AND SUBSTRATE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of March 14, 2008, three times extended from June 14, 2008 to September 14, 2008 by the filing of an appropriate petition and payment for an extension of time submitted herewith, thus providing for timely filing by Monday, September 15, 2008, please amend the above-identified application as follows on the accompanying pages.

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